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Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-1544		SERIAL NO. 09/677.375	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Blalock et al.		GROUP 1765	
FILING DATE October 2, 2000				GROUP 1765			
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Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
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	Document Number	Date	Country	Class	Subclass	Termination	
						Yes	No
AL							
AM							
AN							
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AR		Stanley Wolf and Richard Tauber. Silicon Processing for the VLSI Era, Vol. 1, pp 549, 1986.					
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AT							
EXAMINER				DATE CONSIDERED			
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with 31PEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							